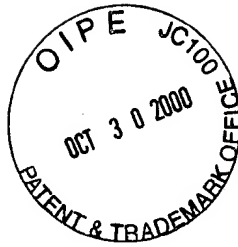


684.3049



PATENT APPLICATION

#4
3.1.01
RW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
	:	Examiner: UNASSIGNED
SHIGETO KAMATA, ET AL.)	
	:	Group Art Unit: 2834
Application No.: 09/619,665)	
	:	
Filed: July 19, 2000)	
	:	
For: LINEAR MOTOR STAGE)	October 30, 2000
SYSTEM FOR USE IN	:	
EXPOSURE APPARATUS)	

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed. The concise explanation of relevance of the Japanese documents is found in the attached English Abstract thereof.

FEE STATEMENT

No fee or statement is required in connection with this Information Disclosure Statement, since it is being submitted prior to the last of (1) issuance of a first official

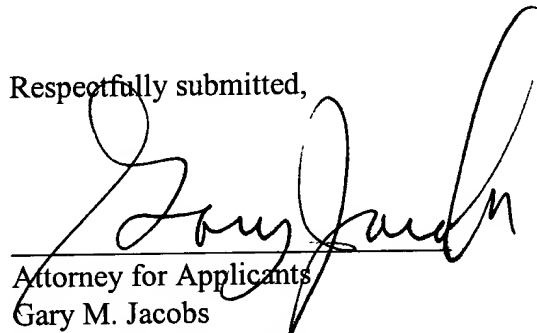
action on the merits or (2) expiration of the three month period following filing of the above-captioned application.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that an initialed copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Gary M. Jacobs
Registration No. 28,861

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
GMJ/vjw